

Attorney Docket No. 740756-2681

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Akiharu MIYANAGA et al.

Application No. 10/728,987

Filed: December 8, 2003

For: PULSED PLASMA CVD METHOD  
FOR FORMING A FILM

) Confirmation No.: 1100

)

) Examiner: W. Markham

) Group Art Unit: 1762

) April 10, 2006

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## AMENDMENT AFTER FINAL REJECTION

## MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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Sir:

In response to the final Office Action mailed January 9, 2006, entry of the following amendments is respectfully requested:

NVA303013.1